

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.
OKI.616

In Re Application Of: Hiroyuki FUKUNAGA



Serial No. NEW	Filing Date JANUARY 22, 2004	Examiner TO BE ASSIGNED	Group Art Unit TO BE ASSIGNED
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Title: METHOD OF MANUFACTURING NONVOLATILE SEMICONDUCTOR STORAGE DEVICE

Address to:

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

37 CFR 1.97(b)

- The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.

37 CFR 1.97(c)

- The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:

the statement specified in 37 CFR 1.97(e);

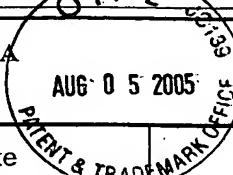
OR

the fee set forth in 37 CFR 1.17(p).

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NEW	JANUARY 22, 2004	TO BE ASSIGNED	TO BE ASSIGNED

METHOD OF MANUFACTURING NONVOLATILE SEMICONDUCTOR STORAGE DEVICE

Payment of Fee

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

A check in the amount of _____ is attached.

The Director is hereby authorized to charge and credit Deposit Account No. _____ as described below.

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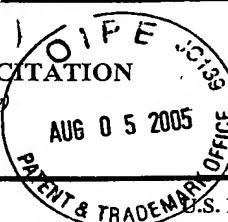
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Dated: JANUARY 22, 2004



INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

AUG 05 2005

Docket Number (Optional)

OKI.616

Application Number

NEW

Applicant

Hiroyuki FUKUNAGA

Filing Date

JANUARY 22, 2004

Group Art Uni

TO BE ASSIGNED

~~MAILED~~ U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
C	06-188431	07/08/1994	JAPAN			✓	
D	05-175508	07/13/1993	JAPAN			✓	
E	62-131582	06/13/1987	JAPAN				✓

OTHER DOCUMENTS (*Including Author, Title, Date, Pertinent Pages, Etc.*)

- 1 -

— 1 —

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

REQUEST FOR EARLY NOTIFICATION OF SERIAL NUMBER

ATTY DOCKET #: OKI.616

MAIL STOP PATENT APPLICATION

APPLICANT: Hiroyuki FUKUNAGA

DUE DATE: October 30, 2004

SERIAL NO.: (NEW)

FILING DATE: January 22, 2004

TITLE: METHOD OF MANUFACTURING NONVOLATILE SEMICONDUCTOR
STORAGE

RECEIPT OF THE FOLLOWING PAPERS IS ACKNOWLEDGED:

- Utility Patent Application Transmittal
- Recordation Cover Sheet including Assignment (2 pages)
- Specification, Claims and Abstract (23 pages)
- Declaration and Power of Attorney (3 Pages)
- 5 Sheets of Drawings for Figures 1-5G
- Transmittal of Information Disclosure Statement, PTO-1449 Form and 4 references
- \$810 Filing Fee (\$770 filing fee, \$40 Assignment Fee)

DATE: January 22, 2004

ATTY: ACV

[Check No. 11346]

